Amendments to the Claims:

- 1. (Canceled)
- 2. (Canceled)
- 3. (Currently amended) The device as claimed in claim 1 An optical reading device having a light source, a movable optical waveguide, an actuator, a detector, and wherein the actuator and detector are integrally formed in a substrate, the movement of the waveguide being effected by action of the actuator thereon, and wherein the detector provides a confocal detection system adapted to effect a detection of light backscattered into cladding of the waveguide, wherein the optical waveguide is formed as an integrated channel guide formed in dielectric materials and surrounded by a cladding of restricted lateral dimensions.
- 4. (Currently amended) The device as claimed in claim $\frac{1}{2}$ wherein the waveguide is externally attached or coupled to the device.
- 5. (Currently amended) The device as claimed in claim ± 3 wherein the optical waveguide is single-moded and polarization- preserving.
- 6. (Currently amended) The device as claimed in claim ± 3 wherein the source is polarized and arranged to excite a single polarization mode of the waveguide.
- 7. (Currently amended) The device as claimed in claim ± 3 wherein the optical waveguide is positioned on a suspended cantilever above a substrate.
- 8. (Original) The device as claimed in claim 7 wherein the waveguide is supported by a mechanical layer along its entire length.
- 9. (Previously amended) The device as claimed in claim 7 wherein the waveguide has a root and is supported only near its root by a mechanical layer.

- 10. (Currently amended) The device as claimed in claim ± 3 wherein the actuator and detector are integrally formed in a silicon based layer.
- 11. (Original) The device as claimed in claim 10 wherein the detector is constructed in the silicon layer as a p-n junction or p-i-n junction photodiode.
- 12. (Currently amended) The device as claimed in claim ± 3 wherein the detector is placed beneath the waveguide to detect cladding modes present in the waveguide.
- 13. (Original) The device as claimed in claim 7 wherein the detector is a photodetector and is placed or formed at the tip of the cantilever.
- 14. (Original) The device as claimed in claim 7 wherein the photodetector is placed near the root of the cantilever.
- 15. (Original) The device as claimed in claim 7 wherein the actuator is placed near the root of the cantilever.
- 16. (Original) The device as claimed in claim 15 wherein the actuator is constructed as an electrothermal or electrostatic drive.
- 17. (Original) The device as claimed in claim 16 wherein the actuator is an electrothermal shape bimorph actuator.
- 18. (Original) The device as claimed in claim 17 wherein the waveguide is placed over a cold arm of the electrothermal shape bimorph actuator.
- 19. (Original) The device as claimed in claim 16 wherein the electrothermal shape bimorph actuator has dual hot arms.

- 20. (Original) The device as claimed in claim 18 wherein electrical current in the cold arm is monitored and suppressed using an active feedback circuit.
- 21. (Original) The device as claimed in claim 17 wherein the motion sensors are placed near the root of the cold arm and the root of the cantilever.
- 22. (Original) The device as claimed in claim 21 wherein the motion sensors are constructed as pairs of piezo-resistors, arranged to detect differential strain caused by bending of the structure and connected to a differential readout circuit.
- 23. (Currently amended) An optical reading system comprising a device having at least one of the following components:
 - a) a cantilevered single-mode optical waveguide suitable for transmitting light onto a target thereby illuminating the target and adapted to effect a reception of the back-scattered signal from the target into the cladding of the waveguide, the optical waveguide being formed as an integrated channel guide formed in dielectric materials and surrounded by a cladding of restricted lateral dimensions,
 - b) an actuator capable of achieving large in-plane displacement,
 - c) motion sensors capable of providing the necessary signals for closed loop control of the scan amplitude,
 - d) a cladding mode detector capable of implementing a confocal detection system so as to effect a detection of the light backscattered into the cladding of the waveguide,
 - e) a lens, which may be formed in the wall of the device package, the device being coupled to a laser source, which may be hybridised or integrally formed with the device of the present invention or linked thereto by a section of optical fibre so as to provide the incident light to the waveguide.
- 24. (Currently amended) The system as claimed in claim 23 wherein the elements a) through e) are all fabricated in silicon-based materials using a compatible process.
- 25. (Currently amended) A method of forming an optical reader comprising the steps of:

- a) forming a detector in a substrate,
- b) forming an actuatable cantilever also in the substrate,
- c) coupling a waveguide to the cantilever, the waveguide being formed as an integrated channel guide formed in dielectric materials and surrounded by a cladding of restricted lateral dimensions, and wherein the cantilever and detector are integrally formed in the substrate, the waveguide being adapted to transmit light onto a target and receive light backscattered from the target, the light received back into the waveguide being detectable using the detector.
- 26. (New) The device as claimed in claim 3 further including at least one motion sensor such that any movement of the waveguide is detectable by the motion sensors.